

RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE REQUESTED EXAMINING GROUP 1765

PATENT

Customer No. 22,852

Attorney Docket No. 7553.0008

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Chishio KOSHIMIZU et al.) Group Art Unit: 1765
Application No: 09/665,940) Examiner: L. UMEZ ERONINI
Filed: September 21, 2000)
For: PLASMA PROCESSING APPARATUS AND PLASMA PROCESSING METHOD	RECEIVED DEC 19 2003 TC 1700
Mail Stop AF Commissioner for Patents P.O. Box 1450	TC 1700

Sir:

Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL

In reply to the Final Office Action dated August 27, 2003, the period for response having been extended to December 27, 2003 by a request for a one month extension of time and fee payment filed concurrently herewith, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment sections of this paper.

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